

EXPEDITED PROCEDURE
Examining Group Number 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| Applicant: | Craig K. Carlson-Stevermer | Examiner: | Jermele M. Hollington |
| Serial No.: | 10/622,849 | Group Art Unit: | 2829 |
| Filed: | July 18, 2003 | Docket No.: | A126.114.102 |
| Due Date: | February 22, 2007 | | |
| Title: | WAFER STAGING PLATFORM FOR A WAFER INSPECTION SYSTEM | | |

AMENDMENT AND RESPONSE UNDER 37 C.F.R. 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This is responsive to the Final Office Action mailed November 22, 2006. Please amend the above-identified patent application as follows:

*Please
enter
gmt*